

<b>Notice of References Cited</b>		Application/Control No. 10/692,147	Applicant(s)/Patent Under Reexamination TANI ET AL.	
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*	B	US-6,720,064 B2	04-2004	Goto, Yasutomo	428/212
*	C	US-2004/0076456 A1	04-2004	Tani et al.	399/329
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	M	US-			

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**NON-PATENT DOCUMENTS**

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